



Please never use task manager

on this computer killing by accident "ACSCRV or 20160426" will turn this tool down for several hours

VPG200 exposure parameters

substrate:

Cr blank - Nanofilm SL (Soda Lime), 5"x5", Cr 90nm, PR AZ1512 530nm

mode	writehead	focus	intensity	focus	cdbias ZX	cdbias ZY	last calibration	design
fast	20mm	pneumatic	27.0%	50	0	0	2016-09-27	SPC20mmV3
standard	4mm	optical	10.0%	35	0	0	2016-09-27	SPC5mmV3
advanced	2mm	optical	9.0%	10	+100	0	2016-09-27	SPC_2mmV5

IMPORTANT: Conversion before 09-09-2016 are not valid

CMi/GAR 2017-08-07

Standard Process

- 1.- Cr-blank 5inch (not older than 2 months)
- 2- Exposure VPG200 (above parameters)
- 3- Develop Hamatech If last login > 2 hours start prg #8: lines purge
prg #1: Develop/Etch/Strip